

**Chemical solution deposition of thin TiO<sub>2</sub>-anatase films for dielectric applications**

Es-Souni, M.; Oja, Ilona; Krunks, Malle Journal of materials science : materials in electronics 2004 / p. 341-344 : ill

**Electrochemical deposition of CuInSe<sub>2</sub>**

Kois, Julia; Kemell, M.; Saloniemi, H.; Ritala, M.; Altosaar, Mare; Mellikov, Enn 2nd Baltic Conference on Electrochemistry : Palanga, Lithuania, 10-12 June : extended abstracts 1999 / p. 87

**Electrochemical deposition of CuInSe<sub>2</sub> thin films for photovoltaic applications = CuInSe<sub>2</sub> õhukesed kiled elektrokeemilise sadestamise meetodil**

Kois, Julia 2006

**Electrochemical deposition of thin polypyrrole films on silicon substrates**

Intelmann, Carl Matthias; Sõrtski, Vitali; Tsankov, Dimiter; Hinrichs, Karsten; Rappich, Jörg 5th ISE Spring Meeting : Dublin (Ireland), 01.-04.05.07 2007 / ? p

**Impact of CdS annealing atmosphere on the performance of CdS-CdTe solar cell**

Maticiuc, Natalia; Spalatu, Nicolae; Mikli, Valdek; Hiie, Jaan Applied surface science 2015 / p. 14-18 : ill

<http://dx.doi.org/10.1016/j.apsusc.2015.01.172>

**Mechanism of changes in the properties of chemically deposited CdS thin films induced by thermal annealing = Keemiliselt sadestatud CdS õhukeste kilede omaduste muutumise mehhanism termilisel lõõmutamisel**

Maticiuc, Natalia 2015

**SnS thin films deposition by chemical solution method and characterization = SnS õhukeste kilede sadestamine keemilisest lahusest ja saadud kilede iseloomustamine**

Safonova, Maria 2016

**Study of ZnO:In, Zn(O,S) and Sb<sub>2</sub>Si<sub>3</sub> thin films deposited by aerosol methods = Aerosoolmeetoditel sadestatud ZnO:In,**

**Zn(O,S) ja Sb<sub>2</sub>Si<sub>3</sub> õhukeste kilede uurimine**

Kriisa, Merike 2017 <https://digi.lib.ttu.ee/i/?7676>

**Thermal annealing of sequentially deposited SnS thin films**

Safonova, Maria; Nair, Padmanabhan Pankajakshy Karunakaran; Mellikov, Enn; Aragon, Rebeca; Kerm, Karin; Naidu, Revathi;

Mikli, Valdek; Volobujeva, Olga Proceedings of the Estonian Academy of Sciences 2015 / p. 488-494 : ill

<http://dx.doi.org/10.3176/proc.2015.4.04>